DOCKET NO: 216932US2

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

NATE APPLICATION OF

MASAKI YAMADA, ET AL. : EXAMINER: GREENE, PERSHELLE L.

SERIAL NO: 10/003,114

FILED: DECEMBER 6, 2001 : GROUP ART UNIT: 2826

FOR: SEMICONDUCTOR DEVICE HAVING BURIED CONDUCTIVE LAYER AND METHOD OF MANUFACTURING

THEREOF

AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action of September 25, 2003, please amend the aboveidentified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks/Arguments begin on page 11 of this paper.